

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/700,466	<b>Applicant(s)/Patent under Reexamination</b> OHMI, TADAHIRO
	<b>Examiner</b> Thien F. Tran	<b>Art Unit</b> 2811

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner